



**ELECTRONIC COPY**

LG770606284  
Report verification at igi.org



January 29, 2026  
IGI Report Number **LG770606284**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **SQUARE EMERALD CUT**  
Measurements **7.57 X 7.43 X 5.00 MM**

**GRADING RESULTS**

Carat Weight **2.56 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**

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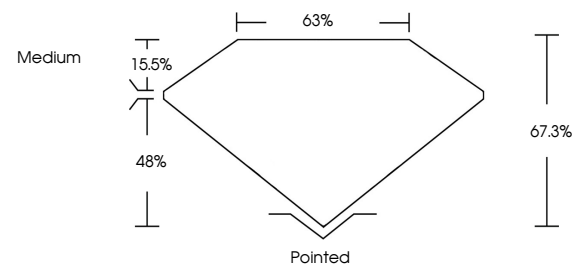
Carat Weight **2.56 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG770606284**

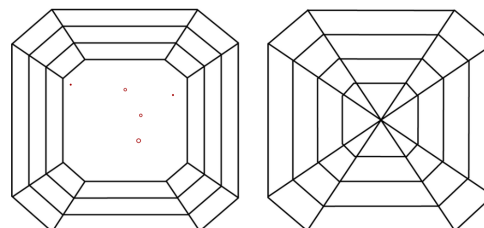
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

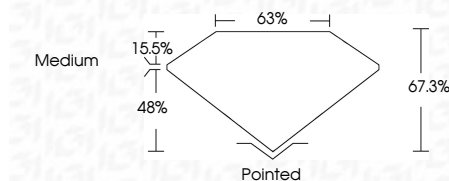
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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IGI Report No **LG770606284**  
**SQUARE EMERALD CUT**  
Carat Weight **2.56 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**  
Depth **48%**  
Table **15.5%**  
Girdle **63%**  
Medium  
Pointed  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG770606284**

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